IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Sujit Sharan

Examiner: Unknown

Serial No.:

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Group Art Unit: 1762

Filed:

THEE

August 29, 2001

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METHODS OF FORMING COATINGS ON GAS-DISPERSION FIXTURES IN

CHEMICAL-VAPOR-DEPOSITION SYSTEMS

POWER OF ATTORNEY BY ASSIGNEE AND CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(b)

DRIGINALLY FILED

Commissioner for Patents Washington, D.C. 20231

Micron Technology, Inc., assignee of the entire right, title and interest in the above-identified application by assignment dated March 12, 2002, which assignment is recorded in the Patent and Trademark Office at Reel 012755, frames 0446 - 0448, hereby appoints the attorneys and agents of the firm of SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A., listed as follows:

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and also attorney Michael L. Lynch (Reg. No. 30,871) of Micron Technology, Inc., as its attorneys with full power of substitution to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith.

The assignee certifies that the above identified assignment has been reviewed and to the best of the assignee's knowledge and belief, title is in the assignee.

Please direct all correspondence regarding this application to the following:

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Dated:	7-1-02	

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By: 12

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